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500.41374CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): S. KANNO, et al

Serial No.: 10/658,281

Filed: September 10, 2003

For: WAFER STAGE FOR PROCESSING APPARATUS AND
WAFER PROCESSING METHOD

Group: 3742

Examiner: S. Fuqua

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the second month subsequent to the shortened statutory period set in the outstanding Office Action mailed May 5, 2004. A payment in the amount of \$430.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (500.41374CX2).

Respectfully submitted,

Melvin Kraus
Registration No. 22,466
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MK/cee
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